

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	11	"6487472"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/11/07 21:38
S2	942	semiconductor adj production and monitor\$5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/10 20:59
S3	42	semiconductor adj production and monitor\$5 and diagnos\$5 and (program software)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/10 20:14
S4	30	semiconductor adj production and monitor\$5 and diagnos\$5 and (program software) and display and (plurality multiple)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/10 20:14
S5	4	"6487472" and plurality and diagnos\$5 and input and output and operation\$4 and display and user	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/10 20:17
S6	5	"6487472" and plurality and diagnos\$5 and input and output and operation\$4 and display	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/10 20:37
S7	0	"6487472" and selectively near5 plurality	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/10 20:37
S8	28	"702"/\$.ccls. and semiconductor adj production and monitor\$5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/10 21:00
S9	72	"700"/\$.ccls. and semiconductor adj production and monitor\$5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/10 21:00

EAST Search History

S10	2	"713"/\$.ccls. and semiconductor adj production and monitor\$5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/11/07 21:34
S11	8	"29"/\$.ccls. and semiconductor adj production and monitor\$5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/10 21:00
S12	42	semiconductor near5 manufactur\$5 same diagnos\$5 same (prior start begin\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/11/07 21:39
S13	15	semiconductor near5 manufactur\$5 same diagnos\$5 near4 (prior start begin\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/11/08 10:20
S14	9	semiconductor near5 manufactur\$5 same diagnos\$5 near4 (prior start begin\$4)near6 manufactur\$5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/11/08 10:23
S15	5	semiconductor near5 manufactur\$5 same diagnos\$5 near4 (prior start begin\$4)near3 manufactur\$5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/11/08 10:25
S16	1	semiconductor near5 manufactur\$5 same diagnos\$5 same preventive adj maintenance	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/11/08 11:01
S17	25	semiconductor near5 manufactur\$5 same diagnos\$5 and preventive adj maintenance	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/11/08 11:01
S18	13	"6,487,472"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/05/01 12:32

EAST Search History

S19	0	"6,487,472" and diagnos\$4 same (prior beginning before) near manufact\$4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/05/01 12:32
S20	0	"6,487,472" and diagnos\$4 same (prior beginning before) near4 manufact\$4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/05/01 12:34
S21	30	semiconductor and diagnos\$4 same (prior beginning before) near4 manufact\$4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/05/01 12:34
S22	1	diagnost\$4 with (before or prior) with (machine or module\$2)with wafer with process\$3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/05/01 13:51
S23	2	diagnost\$4 with (before or prior) with (machine or module\$2)with (semiconductor wafer) with process\$3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2006/05/01 13:51